



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **IBARA, Yoshikazu et al.**

Group Art Unit: 2823

Serial No.: **09/892,893**

Examiner: **COLEMAN, William D.** #6

Filed: **June 28, 2001**

P.T.O. Confirmation No.: 1585

12/21/02
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For. **METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

Date: December 2, 2002

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 1, 2002 for one month from November 1, 2002 to December 1, 2002.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. Two copies of this paper are enclosed herewith.

Respectfully submitted,

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